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INFORMATION
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BY APPLICANTS

Dutta et al.
Applicant

January 3, 2002
Filing Date

Group Art Unit

Examiner's name

U.S. PATENT DOCUMENTS

| Examiner's Initial | Document Number | Date | Name | Class/Sub- class |
|-----------------------|--------------------|------|------|---------------------|
| | NONE | | | |

FOREIGN PATENT DOCUMENTS

| Examiner's Initial | Document Number | Date | Country/Name | Translation ? yes/no |
|-----------------------|--------------------|------|--------------|-------------------------|
| | NONE | | | |


OTHER DOCUMENTS

1. Zhuyikov, S. et al., Stabilized Zirconia-Based NO_x Sensor Using ZnFe₂O₄ Sensing Electrode, Electrochemical and Solid-State Letters, 4 (9), H19-H21 (2001). ✓
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4. Zhuiykov, S. et al., *Potentiometric NO_x Sensor Based on Stabilized Zirconia and NiCr₂O₄ Sensing Electrode Operating High Temperatures*, *Electrochemistry Communications* 3, 97-101 (2001).
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All references were previously considered

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| Examiner  | Date Considered 8/31/01 |
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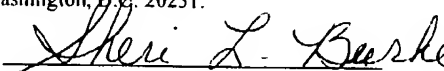
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Sheri L. Burke